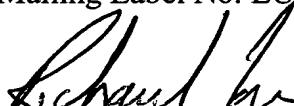


PATENT  
Attorney Docket No. 29925/39028

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jae-chang Jung et al.  
Serial No.  
Filed: HEREWITH  
For: Organic Anti-Reflective  
Coating Composition and Method for  
Forming Photoresist Patterns Using  
the Same  
Group Art Unit: To be determined  
Examiner: To be determined

) CERTIFICATION UNDER 37 CFR 1.10  
)  
) I hereby certify that this paper and the  
documents referred to are being  
deposited with the United States Postal  
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Application, Commissioner for Patents,  
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Richard Zimmermann

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Submitted herewith for consideration by the examiner are copies of the documents identified on the attached Form PTO-1449. Entry and consideration of the submitted documents are solicited.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN

By:



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July 14, 2003

Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. <b>29925/39028</b>	Serial No.
<b>INFORMATION DISCLOSURE STATEMENT</b>		Applicants	
		<b>Jae-chang Jung et al.</b>	
		Filing Date <b>Herewith</b>	Group

<b>U.S. PATENT DOCUMENTS</b>							
*Examiner Initials	Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate	
	<b>5,935,765</b>	<b>08-10-99</b>	Tanaka et al.	<b>430</b>	<b>315</b>		
	<b>6,162,588</b>	<b>12-19-00</b>	Tanaka et al.	<b>430</b>	<b>318</b>		
	<b>6,309,790</b>	<b>10-30-01</b>	Jung et al.	<b>430</b>	<b>270.1</b>	<b>02-07-00</b>	
	<b>6,388,039</b>	<b>05-14-02</b>	Jung et al.	<b>526</b>	<b>329.6</b>	<b>06-22-00</b>	

<b>FOREIGN PATENT DOCUMENTS</b>							
*Examiner Initials	Document Number	Publication Date	Country	Class	Subclass	Translation	
						Yes	No
	<b>EP 1 237 042 A2</b>	<b>09-04-02</b>	EPO	<b>G03F</b>	<b>7/09</b>		
	<b>WO 00/01752 A1</b>	<b>01-13-00</b>	PCT	<b>C08G</b>	<b>18/80</b>	<b>Abstract only</b>	

<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>		

EXAMINER	DATE CONSIDERED
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance <u>and</u> not considered. Include copy of this form with next communication to applicant.</p>	